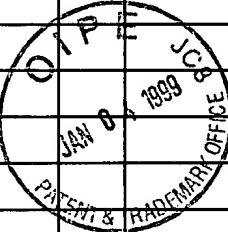


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Form PTO-1449 (Rev. 8-83)			U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No.: 0756-1551		Serial No. 08/691,434	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			Applicant: Shunpei YAMAZAKI et al.					
			Filing Date: August 2, 1996				Group: 2822	
U.S. PATENT DOCUMENTS								
Examiner Initial		Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date (if approp.)	
MW		5,286,296	2/15/94	Sato et al.				
								
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		Document Number	Date	Country	Class	Subclass	Translation Yes No	
OTHER DOCUMENTS (Including Author, Title, Relevant Pages, Date, Place of Publication)								
Examiner	MWilczewski			Date Considered 6/1999				

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Attorney Docket No. 0756-1551

Serial No. 08/691,434

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Applicant: Shunpei YAMAZAKI et al.

Filing Date: 08/02/96

Group: 1107

PATENT & TRADEMARK OFFICE

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
MW	4,370,175	01/25/83	LEVATTER, Jeffrey I.			12/03/79
MW	4,475,027	10/02/84	PRESSLEY, Robert J.			11/17/81
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MW	2-73623	03/13/90	Japan		RECEIVED	ABS
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MW	62-104117	05/14/87	Japan		GROUP 2500	X
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MW		Sera et al., "High-Performance TFT's Fabricated by XeCl Excimer Laser Annealing of Hydrogenated Amorphous-Silicon Film", IEEE Transactions on Electron Devices, Vol. 36, No. 12, December 1989, pp. 2868-2872.
MW		Sameshima et al., "XeCl Excimer Laser Annealing Used to Fabricate Poly-Si TFT's", Japanese Journal of Applied Physics, Vol. 28, No. 10, October 1989, pp. 1789-1793.

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MW	4,313,783	0	DAVIES et al.			05/19/80
MW	4,402,762	0	JOHN et al.			06/02/81
MW	4,405,435	0	TATEISHI et al.			08/26/81
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MW	4,503,807	0	NAKAYAMA et al.			05/29/84
MW	4,523,370	0	SULLIVAN et al.			12/05/83
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MW	02-081424	03/22/90	Japan			ABS
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	03-024717	02/01/01	Japan			ABS

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Examiner *Milczewska*

Date Considered

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Attorney Docket No. 0756-1551

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Applicant: Shunpei YAMAZAKI et al.

Filing Date: 08/02/96

Group: 1107

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MW	4,592,306	0	GALLEGO, Jose M.			11/30/84
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✓ Kuwano, Photovoltaic Behavior of Amorphous Si:H and Si:F:H Solar Cells, Conference Record, 15th IEEE Photovoltaic Specialists Conf., Kissimmee, FL, May 12-15, 1981, Published Aug. 1981, pp. 698-703.

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Examiner *M. W. Yamauchi*

Date Considered

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Applicant: Shunpei YAMAZAKI et al.

Filing Date: 08/02/96

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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MW	4,808,554	02/28/89	YAMAZAKI et al.			11/10/87
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Applicant: Shunpei YAMAZAKI et al.

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